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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Dmitri V. Vezenor et al.
Serial No.: 09/842,214
Title: METHOD OF FABRICATING SUB-MICRON
HEMISPHERICAL AND HEMICYLIDRICAL STRUCTURES
FROM NON-SPHERICALLY SHAPED TEMPLATES
Filed: April 25, 2001
Attorney Docket No.: 1496.00379
Examiner: Ahmed, S.
Art Unit: 1765
In Response To: Office Action mailed September 20, 2004

CERTIFICATE OF MAILING

I hereby certify that this letter, the response or amendment attached hereto are being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 20, 2004.

By:

Jan M Dunbar
Jan M. Dunbar

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 20, 2004 please amend the above-identified application as follows: